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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of)	PROCESS FOR PREPARING
)	NANOSTRUCTURED MATERIALS
Sarkas et al.)	OF CONTROLLED SURFACE
)	CHEMISTRY
Application No.)	Group Art Unit:
)	Examiner:
Filing Date:)	

Commissioner for Patents
P.O. Box 1450
Mail Stop: Patent Application
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Applicant hereby submits the following Preliminary Amendment to the above-referenced application.

Please amend the Specification as set forth in the following amendment.